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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10076070	FILING DATE 02/15/2002	CLASS 096	SUBCLASS 12.2	GAU 120 724	EXAMINER Rodriguez
**APPLICANTS: Suzuki Nobuyasu; Yoshida Takehito; Makino Toshiharu; Yamada Yuka;					
**CONTINUING DATA VERIFIED: <i>N/A</i>					
** FOREIGN APPLICATIONS VERIFIED: JAPAN 2001-37736 02/14/2001					
PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>			
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials			ATTORNEY DOCKET NO SUZUKI28		
TITLE : High-purity standard particles production apparatus and the same particles U.S.DEP.T. OF COMM /PAT.& TM-PTO-436L(Rev. 12-94)					

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NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.	Print Fig.
TERMINAL		Primary Examiner		Application Examiner
DISCLAIMER		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.		

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